

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: In Kui CHO, et al.

Serial No.: New Application Group Art Unit: Not Yet Assigned

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Title: RESONATOR, METHOD FOR MANUFACTURING FILTER BY USING
RESONATOR & FILTER MANUFACTURED BY THE SAME METHOD.

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INFORMATION DISCLOSURE STATEMENT

Honorable Commissioner for Patents
Washington, DC 20231

December 3, 2001

Sir:

As a means of complying with the duty of disclosure under 37 CFR §1.56, and in accordance with 37 CFR §§1.97 and 1.98, Applicant(s), through the undersigned attorney, submits this Information Disclosure Statement. The patents, publications or other information submitted herewith are listed on the attached Form PTO-1449 and copies are attached.

In accordance with 37 CFR §1.97(b)(1) or (2), this Information Disclosure Statement is being filed either within three months of the filing date of the above-identified application, or within three months of the date of entry into the national stage of the above-identified application as set forth in 37 CFR §1.491. Accordingly, no fee is required.

Respectfully submitted,

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Information Disclosure Statements

U.S. Patent Application for
RESONATOR, METHOD FOR MANUFACTURING FILTER BY USING
RESONATOR AND FILTER MANUFACTURED BY THE SAME METHOD

Our Ref. No. P01E7010/US/si

Reference No. : US5834993, US5304962

Papers :

- (1) Analysis and Optimization of Intermodulation in High-T_c Superconducting Microwave Filter Design
- (2) Analysis and Optimization of Passive Intermodulation Distortion in Microwave Filter using Coaxial Line Resonator